

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KOBAYASHI, *et al.*

Serial No.: 10/585,994

Filed: 13 July 2006

For: MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE AND FILM DEPOSITION SYSTEM

Confirmation No. 8859

Art Unit: 2823

Examiner: Kevin A. Parendo

Atty. Dckt: 033082M336

PETITION FOR A THREE-MONTH EXTENSION OF TIME

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for an Extension of Time for a three month period. This Petition for Extension of Time is being concurrently filed with a Response.

Payment of the requisite fee is being made with a credit card using EFS-Web.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP



Michael A. Makuch

Reg. No. 32,263

Date: July 20, 2009

1130 Connecticut Ave., NW, #1130

Washington, D.C. 20036

Telephone: (202) 263-4300

Facsimile: (202) 263-4329